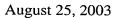


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MAIL STOP PATENT APPLICATION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Re:

Application of Fujio AKAHANE, Nagamitsu TAKASHIMA, Kazushige

HAKEDA, Ryoji UESUGI and Akiharu KUREBAYASHI

FORGING WORK METHOD, AND METHOD OF MANUFACTURING

LIQUID EJECTION HEAD USING THE SAME Assignee: SEIKO EPSON CORPORATION

Our Ref. Q77135

Dear Sir:

Attached hereto is the application identified above comprising sixty (60) sheets of the specification, including the claims and abstract and twenty six (26) sheets of drawings. The requisite U.S. Government filing fee, executed Declaration and Power of Attorney and Assignment will be submitted at a later date.

The Government filing fee is calculated as follows:

Total claims	16 - 20	=	x	\$18.00 =	\$.00
Independent claims	2 - 3	=	_ x	\$84.00 =	\$.00
Base Fee				-	\$750.00

TOTAL FEE . _____\$750.00



MAIL STOP PATEN APPLICATION

August 25, 2003 PAGE 2

Priority is claimed from:

<u>Country</u> <u>Application No</u> <u>Filing Date</u>

JAPAN 2002-243481 August 23, 2002

JAPAN 2003-295584 August 19, 2003

The priority documents will be filed at a later date

Since the anniversary of the first priority date fell on a Saturday, August 23, 2003, the filing of this application on Monday, August 25, 2003 is sufficient to obtain the benefit of priority of all the priority applications.

Respectfully submitted,

SUGHRUE MION, PLLC

Attorneys for Applicant

Darryl Mexic

Registration No. 23,063

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